

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application Serial No. .... 10/816,772  
Filing Date ..... April 1, 2004  
Confirmation No. .... 2790  
Inventor ..... D. V. Nirmal Ramaswamy et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 1792  
Examiner ..... Robert M. Kunemund  
Attorney's Docket No. .... MI22-2520  
Customer No. .... 21567  
Title: Methods Of Depositing An Elemental Silicon-Comprising Material Over  
A Substrate

**RESPONSE TO APRIL 25, 2008 OFFICE ACTION**

To: Mail Stop Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 West First Avenue, Suite 1300  
Spokane, WA 99201-3828

Responsive to the Office Action dated April 25, 2008, Applicant  
amends and remarks as follows:

**AMENDMENTS**